Atty Docket No. JCLA12157

Serial No. 10/605,478

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: Wilson, Christian D.

Group Art Unit: 2824

In re PATENT APPLICATION of

Applicants: Hsiu-Chuan Chu

Serial No.: 10/605,478

Filed: October 02, 2003

For: Silicon Oxide Gap-Filling Process

Examiner: Wilson, Christian D.

Group Art Unit: 2824

MAY 2 4 2005

AMENDMENT

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AMENDMENT AND RESPONSE TO OFFICE ACTION

MAIL STOP Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The Office Action mailed November 24, 2004, has been carefully considered. In response thereto, please enter the following amendment and consider the following

05/26/2005 EFLORES 00000136 500710 10605478 01 FC:1253 1020.00 DA